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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

HM-657PCT

Applicant(s) : Lutz Rose, et al
Serial No. : NOT YET KNOWN (PCT/EP04/04312)
Int. Filed : April 23, 2004
For : METHOD FOR PRODUCING FOAMED SLAG ON
HIGH-CHROMIUM MELTS IN AN ELECTRIC FURNACE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT


S I R:

The attention of the Examiner and of the Patent and Trademark Office is hereby directed to the references cited in the International Search Report, a copy of which is attached. Copies of the references are forwarded herewith and are listed on the attached Form PTO-1449.

With the submission of this admitted prior art, applicant thus complies with the duty of disclosure as set forth at 37 CFR 1.56.


Respectfully submitted,

FK:ml
November 18, 2005
Encls: PTO-1449
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references


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I hereby certify that this correspondence is being deposited with the United States Postal Service Express mail under 37 CFR 1.10 on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.


Friedrich Kueffner

Form PTO-1449

Docket No.: HM-657PCT Serial No.: not known
(PCT/EP04/04312)LIST OF PRIOR ART
CITED BY APPLICANT

Applicant: Lutz Rose, et al

Int. Filing Date: April 23, 2004 Group:

U.S. PATENT DOCUMENTS

Exam Init.	Document Number	Date	NAME	Class Subclass	Filing Date if appropriate
AA					
AB					
AC					
AD					
AE					

FOREIGN PATENT DOCUMENTS

	Document Number	Date	COUNTRY	Class Subclass	TRANSLATION Yes No
AF	697 05 605	11/01	GERMANY		X
/C.C./ AG	0 655 508	5/95	EUROPEAN		X
AH	0 829 545	3/98	EUROPEAN		X
AK	00/14287	2/00	W I P O		X
/C.C./ AL	01/40528	6/01	W I P O		X

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

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EXAMINER: /Christine Chen/

DATE CONSIDERED: 01/18/2008